LIST OF ART CITED BY APPLICANT

(PTO-1449)

OIPE SC1174 APR 26 2005 PATENT & TRADEMARK OFFICE

ATTY. DOCKET NO.	APPLN. SERIAL NO.
P-0571	10/678,156
APPLICANT(S) Guk-Chan LIM	
FILING DATE October 6, 2003	GROUP

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes	Translation No
EOK	2002-0040375	5/30/2002	KOREA (Full Korean Text)			Abst. only	
EOK	06-311107	11/4/1994	JAPAN (Full Japanese Text)			Abst. only	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

EOK	Korean Office Action Dated March 18, 2005

EXAMINER	DATE CONSIDERED
	01/04/06

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line throughbitation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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ATTY. DOCKET NO.	APPLN. SERIAL NO.
P-0571	10/678,156
APPLICANT(S)	
Guk-Chan LIM	
FILING DATE	GROUP
October 6, 2003	2685

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE

U.S. PATENT APPLICATION PUBLICATIONS

	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	

U.S. PATENT APPLICATIONS

	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation Yes	Translation No
[illegible]	06-311107	11/04/1994	JAPAN (with English Abstract)				X
[illegible]	1209713	03/03/1999	CHINA (with English Abstract)				X

OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)

[illegible]	Office Action dated August 26, 2005 in co-pending Chinese Patent Application No. 200310116370.3 (with English Translation)

EXAMINER	DATE CONSIDERED
[signature]	01/04/06

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